

Docket: AM-3245

CERTIFICATE OF MAILING

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Hoiman HUNG et al.

Attorneys Docket: AM-3245

Serial No.:

09/276,376

Art Unit No.: 1746

Filed:

March 25, 1999

Examiner:

A. Olsen

For:

"ENHANCEMENT OF SILICON OXIDE ETCH RATE AND SUBSTRATE

SELECTIVITY WITH XENON ADDITION"

Commissioner of Patents and Trademarks Washington, DC 20231

AMENDMENT UNDER 37 CFR §1.111

Sir:

In response to the Office Action of November 22, 2000, please amend the above application as follows:

In the specification:

Replace paragraph at page 1, lines 9 and 10 with:

This application is related to Serial No. 09/276,311 concurrently filed March 23, 1999 by Hung et al.

05/23/2001 KZEWDIE 00000044 09276376

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